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PTO/SB/21 (09-04) Approved for use through 07/31/2006. OMB 0651-0031 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE aperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. Application Number 10/072.357 RANSMITTAL Filing Date 02/06/2002 First Named Inventor **FORM** Michael D. Kilgore Art Unit 2822 **Examiner Name** Maria F. Guerrero (to be used for all correspondence after initial filing) Attorney Docket Number NVS014 US

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ENCLOSURES (Check all that apply)								
	Fee Tran	smittal Form		Drawing	g(s)			After Allowance Communication to TC Appeal Communication to Board
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Certified Copy of Priority Document(s) Reply to Missing Parts/ Incomplete Application Reply to Missing Parts under 37 CFR 1.52 or 1.53			Remarks Please charge any required fee(s) to Deposit Account No. 50-2263					
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT								
Firm Name		Silicon Valley Patent Grou	· · · · · · · · · · · · · · · · · · ·					
Signature		Warnel & Steerten						
Printed name		David E. Steuber						
Date		05/27/2006				Reg. No.	25,557	,

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David E. Steuber

Date 05/27/2006

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

10/072,357

Confirmation No. 4288

First Inventor

Michael D. Kilgore

Filing Date

2/6/2002

Tech. Center/

2822

Examiner

Maria F. Guerrero

Art Unit

Title:

High Density Plasma Process For Optimum Film Quality And

Electrical Results

Docket No.:

NVS014 US

Customer No.:

34036

Santa Clara, California May 27, 2006

Mail Stop Amendment COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

<u>AMENDMENT</u>

Dear Sir:

In response to the Office Action dated February 28, 2006, please amend the aboveidentified application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.